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CENTRAL FAX CENTER**JUN 16 2006****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**
(Attorney Docket No. 100176)

First Inventor: Roland K. Sevilla

Serial No.: 10/601,601

Filing Date: 06/23/2003

Title: **POLISHING PAD FOR
ELECTROCHEMICAL-
MECHANICAL POLISHING**

Examiner: Maurina T. Rachuba

Art Unit: 3723

Certificate of Facsimile TransmisionI, Mariejose Monsalve, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on 16 JUN 06.
(Sender's signature)Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**RESPONSE TO OFFICE ACTION**

This is a reply to the Office Action mailed June 7, 2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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